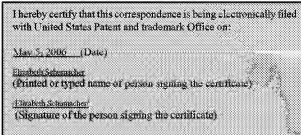


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: K.R. Udayakumar, *et al.*
Serial No.: 10/721,932
Filed: November 25, 2003
Title: A METHOD FOR ETCHING A SUBSTRATE AND A DEVICE
FORMED USING THE METHOD
Grp./A.U.: 1765
Examiner: Lan Vinh

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir:

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

In response to the Examiner's Action mailed March 6, 2006, please reconsider the above-identified application for the following reasons: